

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **Naoto HORIGUCHI**

Serial Number: **Not Yet Assigned**

Filed: **February 2, 2004**

For: **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME**

Attorney Docket No. **042073**

Customer No.: **38834**

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

February 2, 2004

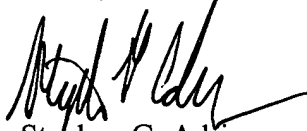
Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,  
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Enclosures: PTO-1449; References (5)

<b>INFORMATION DISCLOSURE STATEMENT PTO-1449</b>	Attv. Docket No. 042073	Serial No. New Appln.
	Applicant(s): Naoto HORIGUCHI	
	Filing Date: February 2, 2004	Group Art Unit:

### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					

### FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____	AC		
_____	AD		
_____	AE		
_____	AF		

### OTHER DOCUMENTS

_____	AG	Patent Abstracts of Japan, Publication No. 05267331, dated October 15, 1993.
_____	AH	Patent Abstracts of Japan, Publication No. 06224381, dated August 12, 1994.
_____	AI	Patent Abstracts of Japan, Publication No. 06338591, dated December 6, 1994.
_____	AJ	Patent Abstracts of Japan, Publication No. 11163157, dated June 18, 1999.
_____	AK	Patent Abstracts of Japan, Publication No. 2000196077, dated July 14, 2000.

Examiner	Date Considered
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